INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 22, 2026

IGI Report Number	LG829610798
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MODIFIED BRILLIANT
Measurements	10.79 X 7.61 X 4.90 MM

GRADING RESULTS

Carat Weight	3.54 CARATS
Color Grade	E
Clarity Grade	VS 1

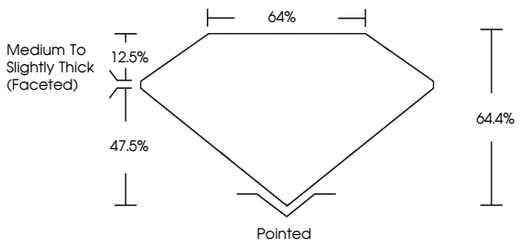
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG829610798

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG829610798
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

© IGI 2020, International Gemological Institute

FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

www.igi.org

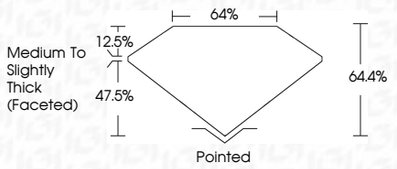
LABORATORY GROWN DIAMOND REPORT

August 22, 2026

IGI Report Number	LG829610798
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MODIFIED BRILLIANT
Measurements	10.79 X 7.61 X 4.90 MM

GRADING RESULTS

Carat Weight	3.54 CARATS
Color Grade	E
Clarity Grade	VS 1



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG829610798

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

August 22, 2026
IGI Report No LG829610798
CUSHION MODIFIED BRILLIANT
10.79 X 7.61 X 4.90 MM
Carat Weight 3.54 CARATS
Color Grade E
Clarity Grade VS 1
Depth 64.4%
Table 64%
Girdle Medium To Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG829610798
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa